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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/673,390	09/29/2003	Mark Bernard Hettish	2003P08063US	4143
7590 09/10/2010 Attn: Elsa Keller, Legal Administrator Siemens Corporation Intellectual Property Department 170 Wood Avenue South Iselin, NJ 08830			EXAMINER PADMANABHAN, KAVITA	
			ART UNIT 2161	PAPER NUMBER
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Appeal No: 2010-011814
Application: 10/673,390
Appellant: Mark Bernard Hettish et al.

Board of Patent Appeals and Interferences Docketing Notice

Application 10/673,390 was received from the Technology Center at the Board on September 07, 2010 and has been assigned Appeal No: 2010-011814.

In all future communications regarding this appeal, please include both the application number and the appeal number.

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The facsimile number of the Board is 571-273-0052. Because of the heightened security in the Washington D.C. area, facsimile communications are recommended. Telephone inquiries can be made by calling 571-272-9797 and referencing the appeal number listed above.

By order of the Board of Patent Appeals and Interferences.